## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hisaji OYAKE et al.

Application No.: New

U.S.

National

Stage of

PCT/JP03/00020

Filed: July 7, 2004

Docket No.: 120321

For:

METHOD OF MANUFACTURING STAMPER FOR MANUFACTURING INFORMATION MEDIUM, STAMPER, AND PHOTORESIST MASTER

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein. one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of 1. the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- $\boxtimes$ The references 1 and 4-12 were cited in a counterpart foreign application. An 2. English language version of the foreign search report is attached for the Examiner's information.
- $\boxtimes$ English-language Abstracts of the non-English language references 1-12 are attached hereto.

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4. A computer-generated English translation of the following Japanese references have been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and are attached, but have not been reviewed for accuracy. See References 2 and 4-12.

Respectfully submitted,

Registration No. 27,075

Joel S. Armstrong Registration No. 36,430

JAO:JSA/emt

Date: July 7, 2004

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Sheet <u>1</u> of <u>1</u> Form PTO-1449 US Dept. of Commerce ATTY DOCKET NO. APPLICATION NO. (REV. 8-83) PATENT & TRADEMARK OFFICE 120321 New U.S. National Stage of INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) **APPLICANTS** Hisaji OYAKE et al. **FILING DATE** July 7, 2004 U.S. PATENT DOCUMENTS **EXAMINER** SUB INITIAL DOCUMENT NUMBER DATE NAME **CLASS CLASS** FOREIGN PATENT DOCUMENTS SUB DOCUMENT NUMBER DATE COUNTRY **CLASS CLASS** 1 JP A 4-263140 w/abstr. 09/18/1992 Japan 2 JP A 9-292715 w/abstr. + trans. 11/11/1997 Japan 3 JP A 3-180476 w/abstr. 08/06/1991 Japan 4 JP A 7-147026 w/abstr. + trans. 06/06/1995 Japan 5 JP A 2001-344831 w/abstr. + trans. 12/14/2001 Japan 6 JP A 2001-202661 w/abstr. + trans. 07/27/2001 Japan 7 JP A 2000-21033 w/abstr. + trans. 01/21/2000 Japan 8 JP A 6-215422 w/abstr. + trans. 08/05/1994 Japan JP A 8-273219 w/abstr. + trans. 10/18/1996 Japan 10 JP A 5-214547 w/abstr. + trans. 08/24/1993 Japan 11 JP A 8-283950 w/abstr. + trans. 10/29/1996 Japan 12 JP A 9-109276 w/abstr. + trans. 04/28/1997 Japan OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in

conformance and not considered. Include copy of this form with next communication to applicant.

Date: <u>July 7, 2004</u>

**EXAMINER** 

Examiner: